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2814  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of )  
Kazuo MAEDA ) Examiner: Quach  
Serial No.: 09/519,599 / ) Art Unit: 2814  
Filed: March 6, 2000 )  
For: METHOD AND APPARATUS FOR )  
FORMING AN INTERLAYER )  
INSULATING FILM AND )  
SEMICONDUCTOR DEVICE )

RESPONSE TO OFFICE ACTION OF APRIL 23, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the office action of April 23, 2003, please amend the captioned application as follows:

RECEIVED  
AUG 18 2003  
TECHNOLOGY CENTER 2800